

Overview lectures MSc Cryst. Mat. 2nd semester summer term 2020

Lecturer	Lecture	Lecture type	Start of lecture	Examination	Examination date	Module / resp. lecturer
Danilewsky	Crystal Defects	manuscript/literature	11.5.	written (module-) exam	27.7.20, 9-11 am	Defects / Danilewsky
	Crystal Physics	manuscript/literature	11.5.	written (module-) exam	29.7.20, 9-11 am	Applied Materials I / Danilewsky
	Growth Kinetics	manuscript/literature	11.5.	written (module-) exam	24.7.20, 9 am-12 pm	Crystal Growth / Danilewsky
	Advanced Analytics with Synchrotron Radiation I	manuscript/literature	11.5.	report		Methods & Concepts / Danilewsky
	Crystal Growth Methods II - THM	Lab course	start 3.8.20	report		Crystal Growth / Danilewsky
	Crystal Preparation - THM	Lab course	start 3.8.20	report		Crystal Growth / Danilewsky
Fiederle	Semiconductors	Zoom/Video	12.5. / 9.00	written (module-) exam	29.7.20, 9-11 am	Applied Materials I / Danilewsky
	Semiconductor Devices	Zoom/Video	12.5. / 15.00	presentation		Methods & Concepts / Fiederle
	High-Resolution Spectroscopy	manuscript/literature		t.b.d.		Advanced Analytical Methods / Fiederle
	Epitaxy	Zoom/Video	13.5. / 11.00	written (module-) exam	24.7.20, 9 am-12 pm	Crystal Growth / Danilewsky
	Electrical & Optical Characterization Methods	Zoom/Video	14.5. / 10.00	written (module-) exam	27.7.20, 9-11 am	Defects / Danilewsky
Jauß	Purification & Doping Methods	Zoom	14.5. / 13.15	written exam	30.7.20, 1-3 pm	Methods & Concepts / Danilewsky
Remhof	X-Ray Diffraction by Crystals	Zoom	11.5. / 13.00	t.b.d.		Advanced Analytical Methods / Fiederle
Sorgenfrei	In-House Seminar	Zoom	on appointment			
	Crystal Growth Methods II - Bridgman	Lab course	start 3.8.20	report		Crystal Growth / Danilewsky
	Crystal Preparation - Bridgman	Lab course	start 3.8.20	report		Crystal Growth / Danilewsky
N.N.	Sustainability	t.b.d.	t.b.d.	t.b.d.		

Overview written exams and responsible lecturers

Danilewsky	Defects	27.7.20, 9-11 am
	Applied Materials I	29.7.20, 9-11 am
	Crystal Growth	24.7.20, 9 am-12 pm
	Purification & Doping (Jauß)	30.7.20, 1-3 pm

Overview other examination types and responsible lecturers

Danilewsky	Crystal Growth	report
	Synchrotron Radiation	report
Fiederle	Advanced Analytical Methods	presentation
	Semiconductor Devices	presentation
Sorgenfrei	Crystal Growth	report